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35.C12395

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: )  
YOSHIHIKO FUKUMOTO ET AL. ) Examiner: V. Perez Ramos  
Application No.: 09/429,530 ) Group Art Unit: 1765  
Filed: October 28, 1999 )  
For: METHOD FOR FABRICATING )  
SEMICONDUCTOR DEVICE ) October 29, 2001

Assistant Commissioner for Patents  
Washington, D.C. 20231

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TC 1700

INFORMATION DISCLOSURE STATEMENT

Sir:

In compliance with the duty of disclosure under 37 C.F.R. § 1.56 and in accordance with the practice under 37 C.F.R. §§ 1.97 and 1.98, the Examiner's attention is directed to the document listed on the enclosed Form PTO-1449. A copy of the listed document is enclosed.

The listed document was cited in a European Search Report in a European patent application corresponding to the above-identified application. A copy of this search report is included.

CONCLUSION

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

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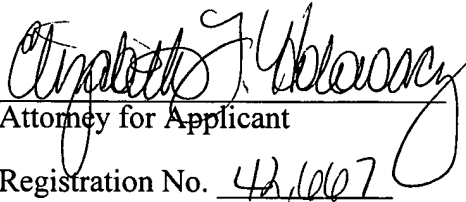
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(fee refunded)

Applicant's undersigned attorney may be reached in our New York office by telephone at (212) 218-2100. All correspondence should continue to be directed to our address given below.

Respectfully submitted,

  
Attorney for Applicant  
Registration No. 42,1067

FITZPATRICK, CELLA, HARPER & SCINTO  
30 Rockefeller Plaza  
New York, New York 10112-3801  
Facsimile: (212) 218-2200